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TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

Application Number	10/632,825
Filing Date	August 4, 2003
Inventor(s)	Yun-Jung LEE et al.
Group Art Unit	2826
Examiner Name	Evan T. Pert
Attorney Docket Number	9862-000016/US

ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form	<input type="checkbox"/> Assignment Papers (for an Application)	<input type="checkbox"/> After Allowance Communication to Group
<input type="checkbox"/> Fee Attached	<input type="checkbox"/> Letter to the Official Draftsperson and _____ Sheets of Formal Drawing(s)	<input type="checkbox"/> LETTER SUBMITTING APPEAL BRIEF AND APPEAL BRIEF (w/clean version of pending claims)
<input checked="" type="checkbox"/> Amendment	<input type="checkbox"/> Licensing-related Papers	<input type="checkbox"/> Appeal Communication to Group (Notice of Appeal, Brief, Reply Brief)
<input type="checkbox"/> After Final	<input type="checkbox"/> Petition	<input type="checkbox"/> Proprietary Information
<input type="checkbox"/> Affidavits/declaration(s)	<input type="checkbox"/> Petition to Convert to a Provisional Application	<input type="checkbox"/> Status Letter
<input type="checkbox"/> Extension of Time Request	<input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address	<input type="checkbox"/> Other Enclosure(s) (please identify below):
<input type="checkbox"/> Express Abandonment Request	<input type="checkbox"/> Terminal Disclaimer	
<input type="checkbox"/> Information Disclosure Statement	<input type="checkbox"/> Request for Refund	
<input type="checkbox"/> Certified Copy of Priority Document(s)	<input type="checkbox"/> CD, Number of CD(s) _____	
<input type="checkbox"/> Response to Missing Parts/ Incomplete Application		Remarks
<input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53		MAIL STOP AF

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm or Individual name	Harness, Dickey & Pierce, P.L.C.	Attorney Name	Reg. No.
Signature			
Date	December 7, 2005		



PATENT
9862-000016/US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Yun-Jung LEE et al. CONF. NO.: 9195
SERIAL NO.: 10/632,825 GROUP: 2826
FILED: August 4, 2003 EXAMINER: Evan T. Pert
FOR: METHOD OF FORMING OXIDE LAYER USING ATOMIC
LAYER DEPOSITION METHOD AND METHOD OF FORMING
CAPACITOR OF SEMICONDUCTOR DEVICE USING THE
SAME

AMENDMENT AFTER FINAL

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop AF

December 7, 2005

Dear Sir:

Responsive to the Final Official Action dated October 17, 2005, the following amendments and remarks are respectfully submitted in connection with the above-referenced application.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 13 of this paper.